



Development of Soft X-ray Source using Laser Compton Scattering

R. Kuroda^{*}, S. Kashiwagi^{*}, M. Washio^{*}, T. Hirose^{*},
Y. Hama^{*}, J. Urakawa^{**}, H. Hayano^{**}, X. J. Wang^{***}

^{*} Waseda University, Japan

^{**} KEK, Japan

^{***} BNL, USA

Out Line



•Introduction

- About our project
- Approach to the soft X-ray source
- X-ray microscopy

•High quality electron beam generation system

- Photo-cathode RF-gun system
- Ng:YLF Laser system
- Jitter measurement of laser

Time domain demodulation technique

- Electron beam diagnostics

•Laser Compton scattering experiment

- Experimental setup
- Estimation of generated X-ray
- Back ground measurement

•Summary & Future Plan

Research Project at Waseda University



1999~

New research Project

“High-Tech Research Center Project”

(Ministry of Education, Culture, Sports, Science and Technology & Waseda University)

Purpose

**High quality electron beam generation
and Application Experiment
(pulse radiolysis and soft X-ray generation)**

2000/9

Construction of new building completed

2001~

Main components installed

2002/4

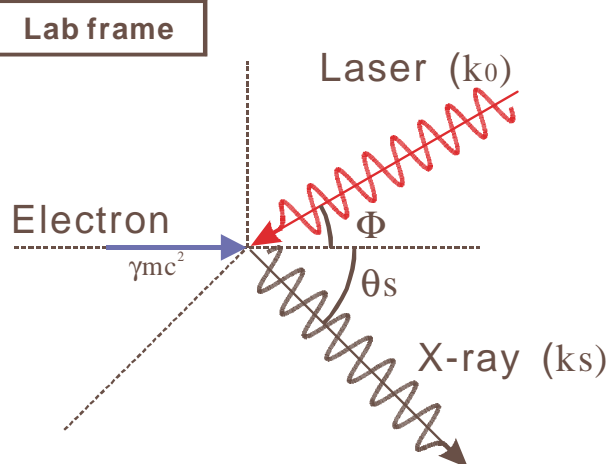
Approval for our rf-gun system

~ **Beam Experiment**



Soft X-ray Source

- **Laser Compton Scattering**
between electron beam and laser pulse
 - Short pulse X-ray
 - High intensity per pulse
 - **Compact**
 - Variable energy
 - **Arbitrary energy spectrum**



- Collision angle
- Laser wavelength
- Electron beam energy
- **Detected angle**
- etc.

X-ray microscopy



Soft X-ray

(absorbed in Oxygen, Nitrogen, Carbon)



“Water window”

(250-500 eV : 2.5-5 nm)

Abs-Coeff.(water)

< Abs_Coeff. (protein)

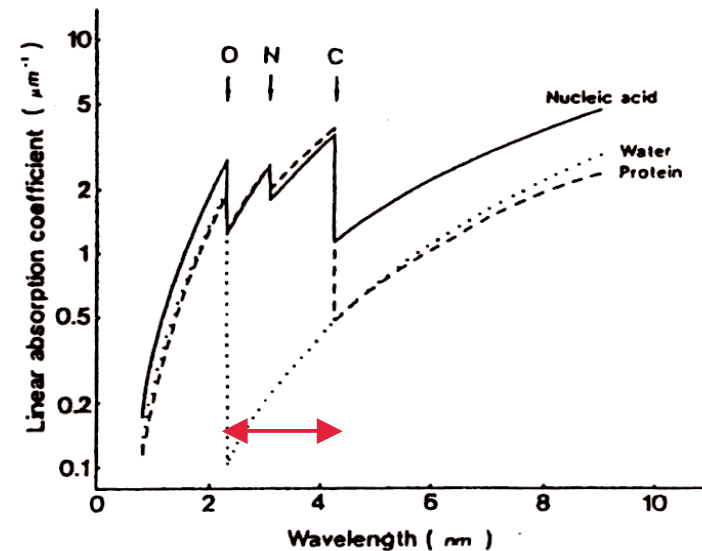


**Dehydration of the specimens
Not necessary**

Biological observation

1. Short Pulse
⇒ Less Irradiation Damage
2. Variable Energy
⇒ image contrast
3. Compact
⇒ Stable

Element	K-shell absorption edge [nm] ([eV])
O	2.332 (531.73)
N	3.099 (400.13)
C	4.368 (283.88)





High quality electron beam generation

Photo-cathode RF-GUN system

(BNL type 1.6 cell S-band rf-gun)

1. Low emittance beam

High field acceleration

--- suppress emittance growth due to space charge effect

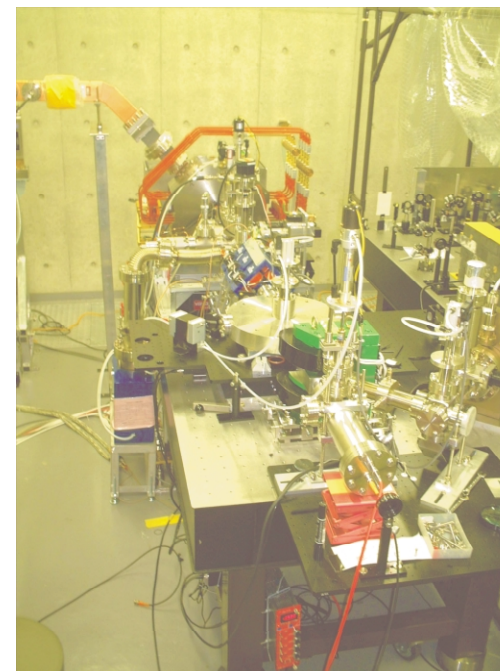
2. Short bunch beam

Time structure of beam is controlled laser pulse

Not necessary buncher system → compact

- *Stable rf source*
- *Stable laser system*

- *Beam diagnosis*





Laser System

Laser Medium	Nd:YLF
Pulse Width (FWHM):	10 ps
Pulse Energy	
UV (262 nm) / IR(1047 nm)	200 uJ / 2 mJ
Repetition Rate	1-25 Hz (usually 5 Hz)



- **Timing stabilizer
(119MHz seed light)**
- **Intensity stabilizer
(25 Hz UV light)**

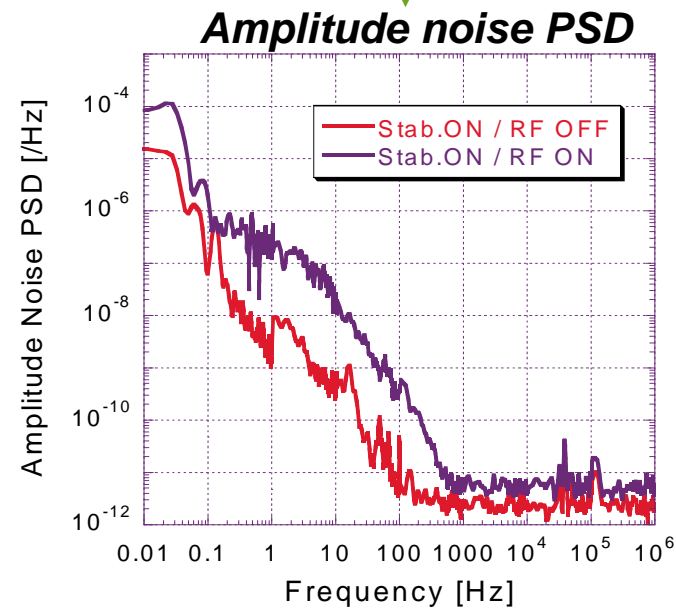
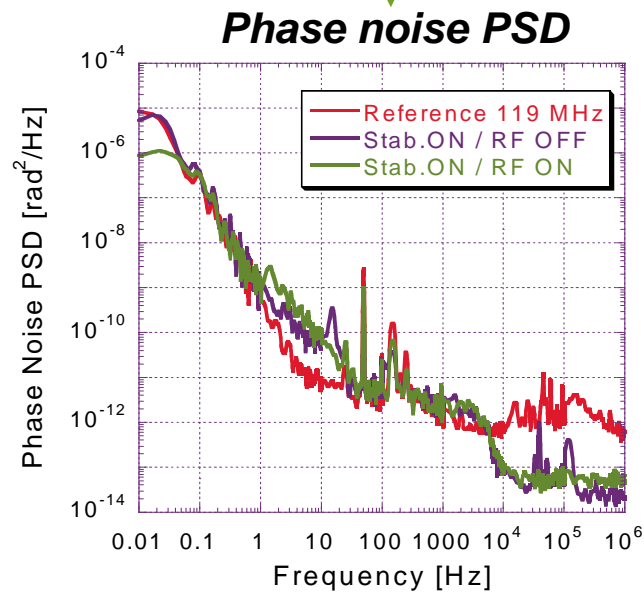
Jitter measurement (with RF dependence)



Time domain demodulation technique
(Vector Signal Analyzer)

119 MHz laser signal

demodulation



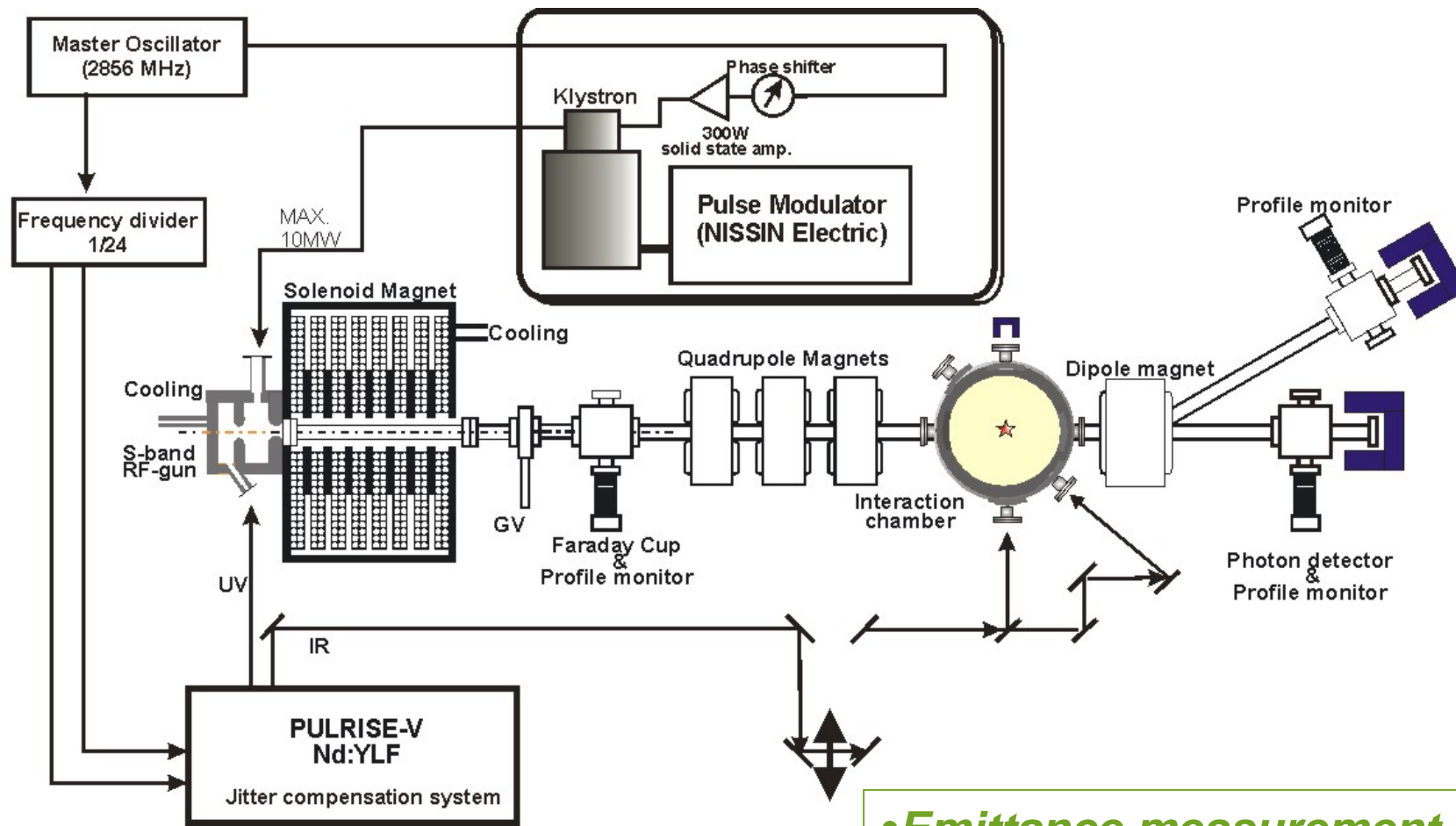
rms timing jitter

Reference 119 MHz	0.26 ps
RF ON	0.26 ps
RF OFF	0.25 ps

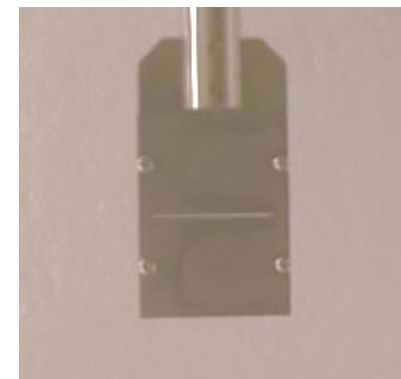
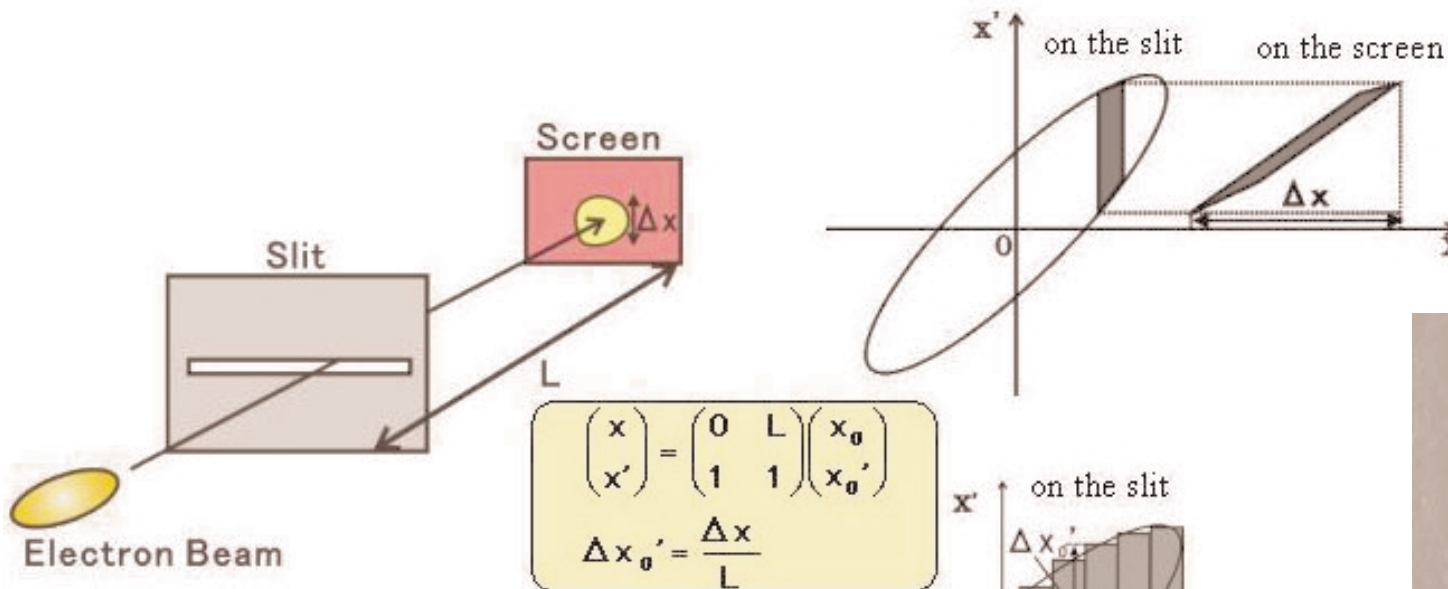
rms amplitude jitter

RF ON	0.11 %
RF OFF	0.03 %

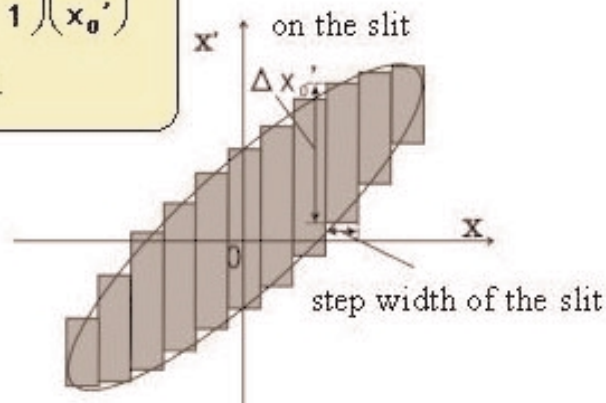
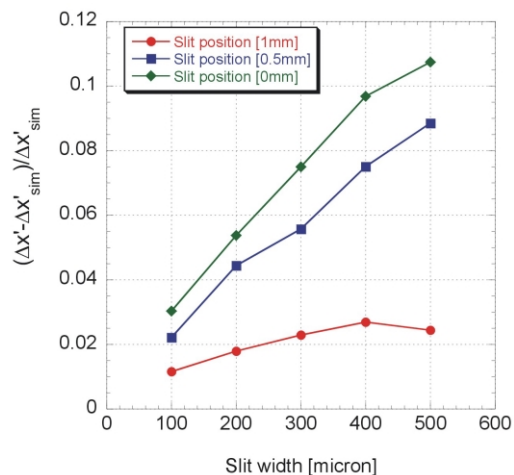
Beam line and Beam diagnostics



Emittance Measurement (Slit Scan)

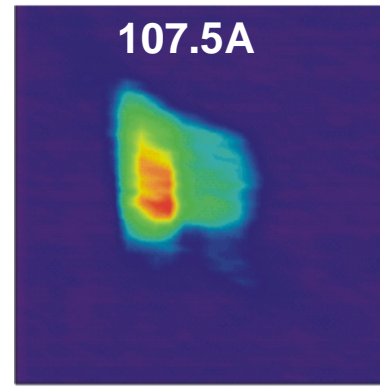
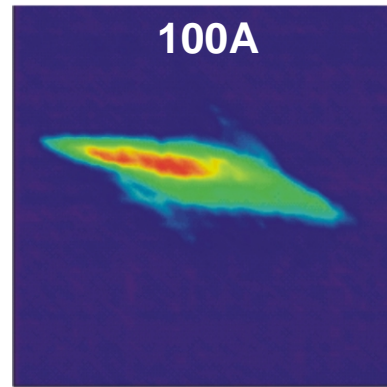
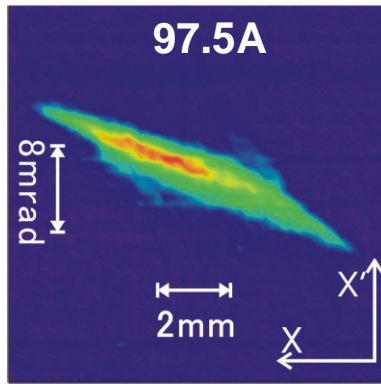


200um width tungsten slit



Beam Emittance has been measured using the single slit scan technique changing the solenoid current.

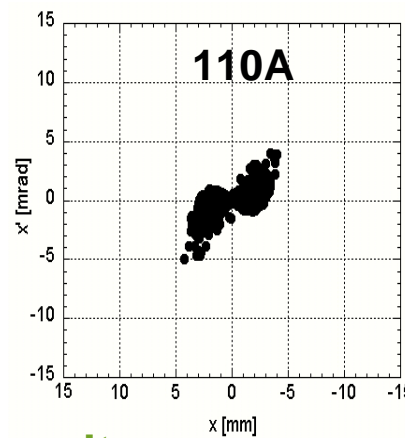
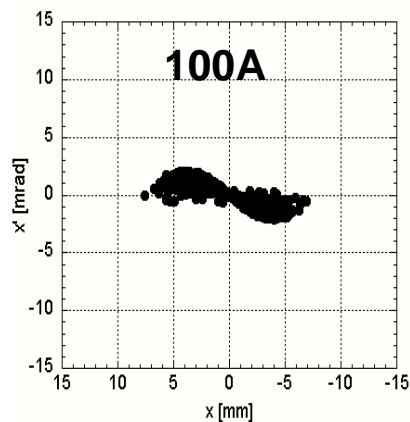
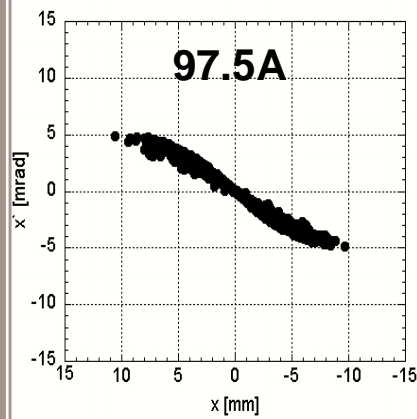
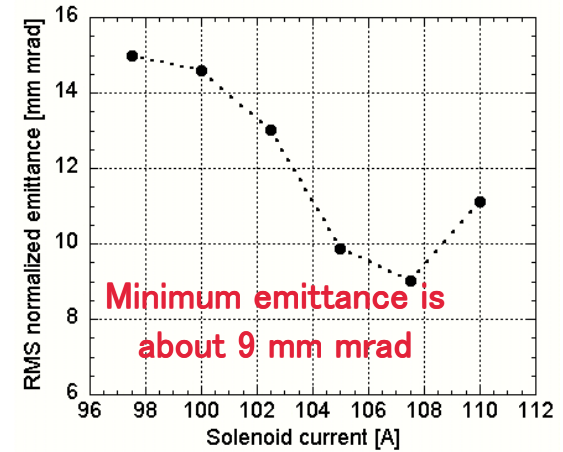
Emittance Measurement Results and Simulation Results (Parmela)



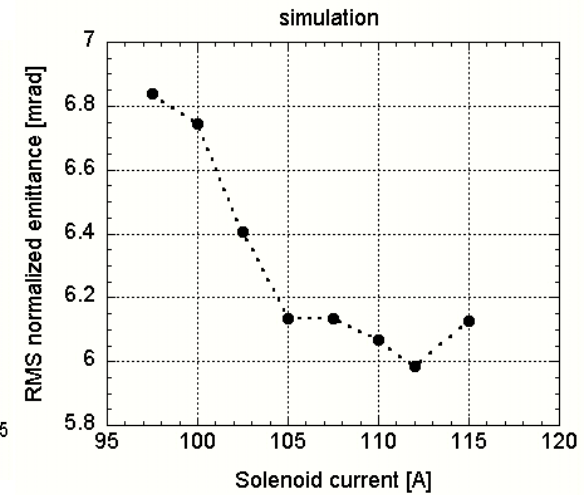
m2

m5

Experimental results



Simulation results



Laser Compton Scattering Experiment

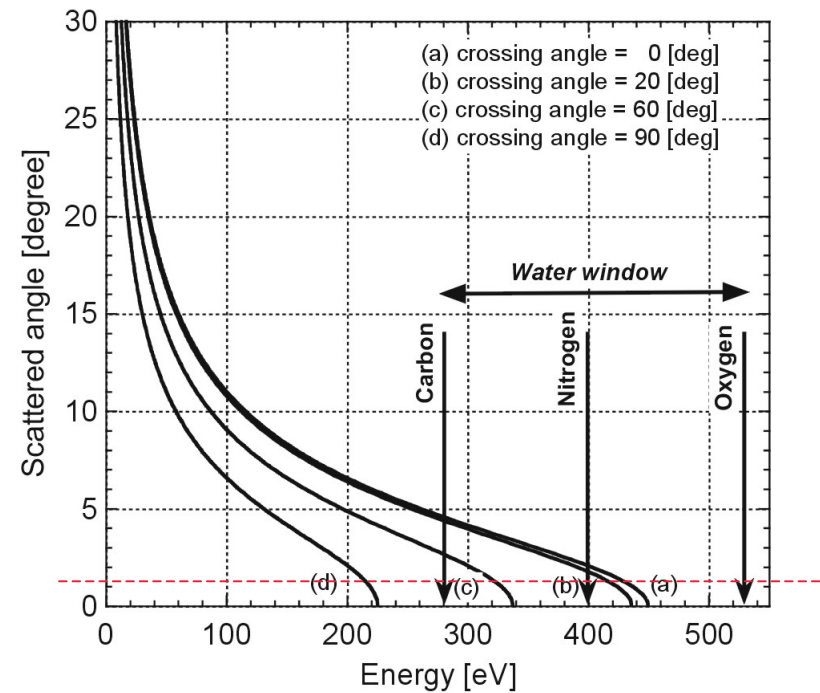
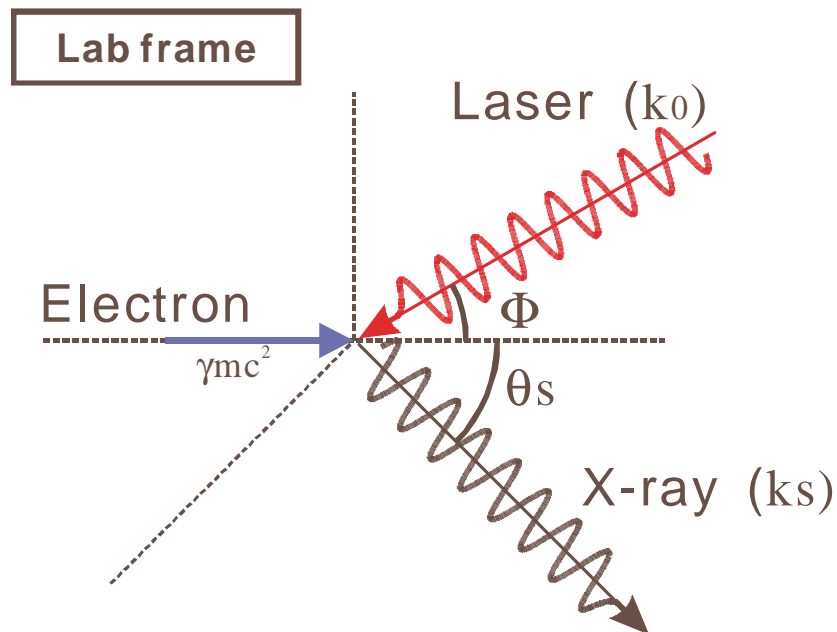


Energy of generated X-ray

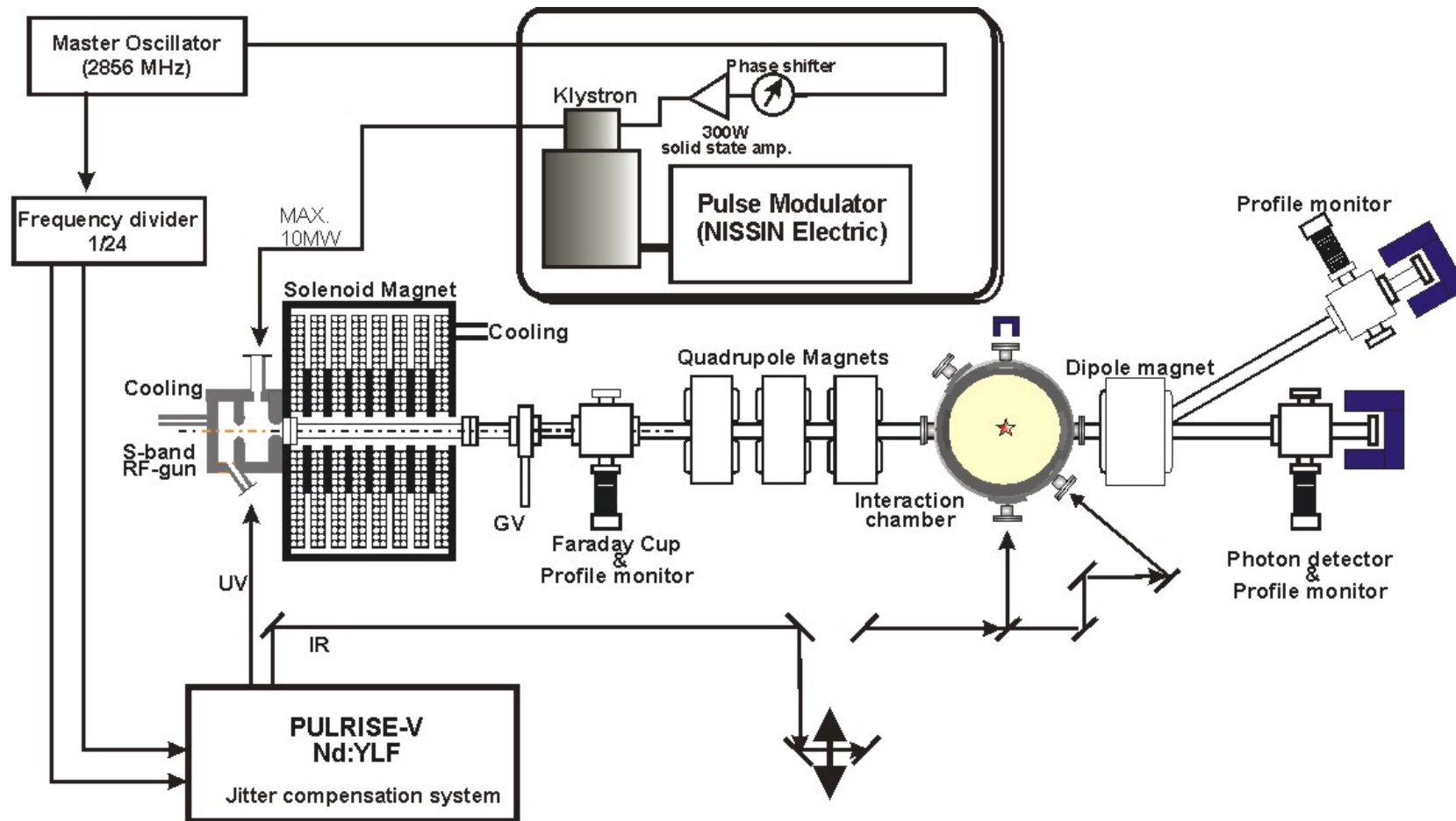
$$k_s = \frac{\gamma^2 m_0 c^2 (1 + \beta \cos \phi)(1 - \beta^2) k_0}{m_0 c^2 (1 - \beta \cos \theta) + (1 - \beta)(1 + \cos \theta)(1 + \beta \cos \phi) \gamma k_0}$$

Electron beam : 5 [MeV]

Laser light (Nd:YLF) : 1047 [nm]



Experimental Setup of Laser Compton Scattering





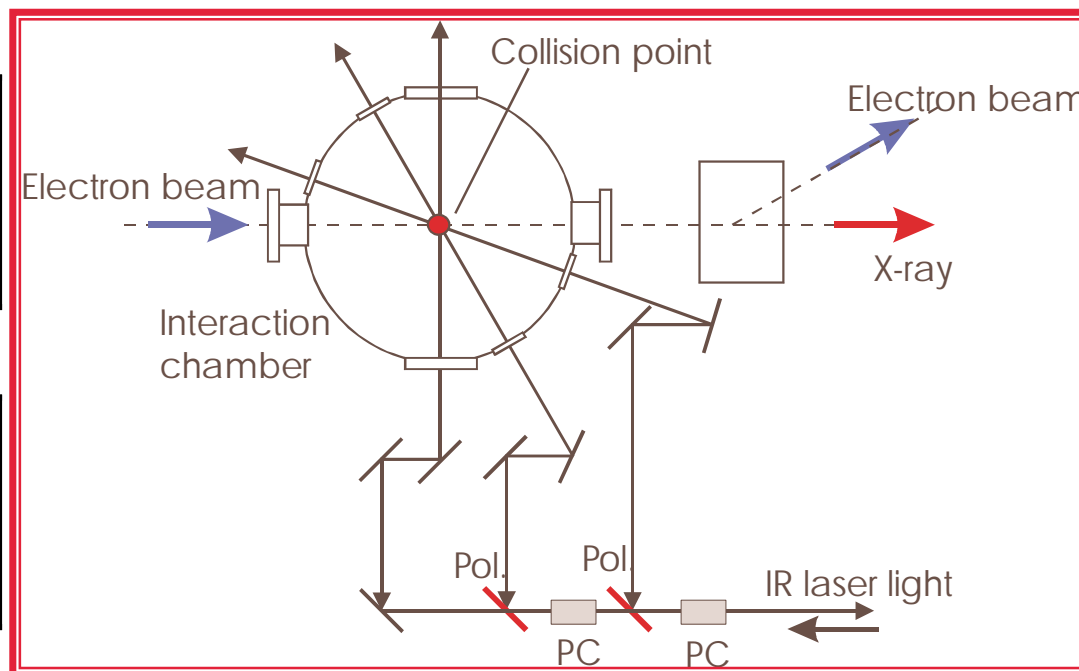
Requirement of Beam Parameters

Electron beam

Beam energy	5.0 MeV
Bunch charge/bunch	2 nC
Bunch length (FWHM)	10 ps
Beam size at focal point (σ_x/σ_y)	100/100 μm

Nd:YLF laser

Wave length	1047 nm
Energy/pulse	100 mJ
Pulse length (FWHM)	10 ps
Beam size at focal point (σ_x/σ_y)	30/30 μm



Generated X-ray

Collision angle (ϕ)	Ave. photon energy [eV]	Number of Photons [/ pulse]
20	435 (1.1% band width)	1.1×10^5
60	333 (1.1% band width)	3.4×10^4
90	222 (1.1%band width)	2.0×10^4

(within 20 m rad of detected angle)

Our Present Status



Electron beam

Beam energy	5.0 MeV
Bunch charge/bunch	0.5 nC
Bunch length (FWHM)	10 ps
Beam size (σ_x/σ_y)	300/300 μm

Nd:YLF laser

Wave length	1047 nm
Energy/pulse	1 mJ
Pulse length (FWHM)	10 ps
Beam size (σ_x/σ_y)	60/60 μm

Generated X-ray (within 20 m rad of detected angle)

Collision angle (ϕ)	Ave. photon energy [eV]	Number of Photons [/ pulse]
20	435 (1.1% band width)	26
60	333 (1.1% band width)	11
90	222 (1.1% band width)	6

Can't detect the X-ray signal



Laser Amplification



Near Future plan

Laser Amplification with flash lump pumped
Nd:YLF Crystal 2-pass Amplifier system



Under constructing

Up to 40 mJ/pulse

Electron beam

Beam energy	5.0 MeV
Bunch charge/bunch	0.5 nC
Bunch length (FWHM)	10 ps
Beam size (σ_x/σ_y)	200/200 μm

Nd:YLF laser

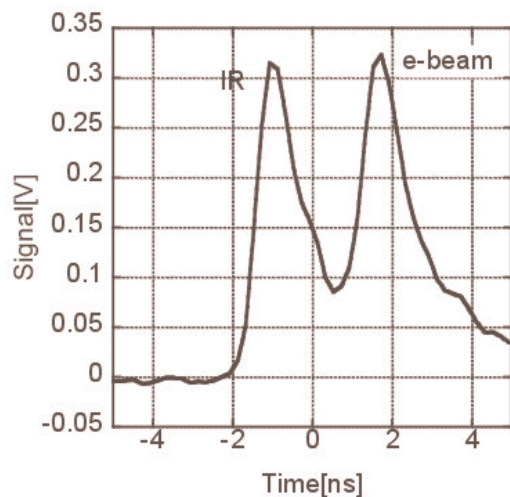
Wave length	1047 nm
Energy/pulse	40 mJ
Pulse length (FWHM)	10 ps
Beam size (σ_x/σ_y)	60/60 μm

Generated X-ray (within 12 m rad of detected angle due to MCP size)

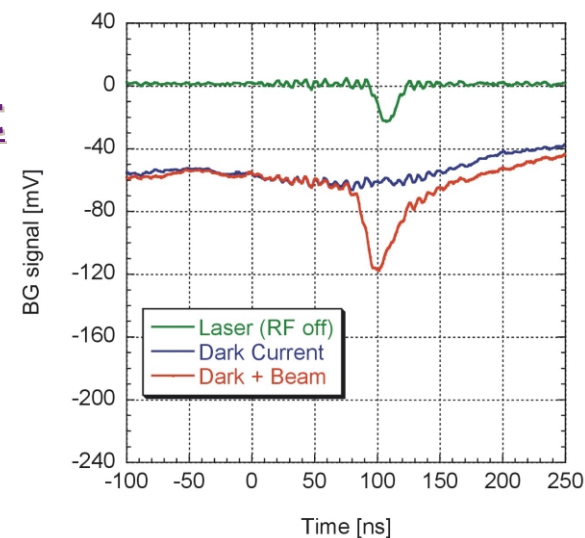
Collision angle (ϕ)	Ave. photon energy [eV]	Number of Photons
20	435 (0.39% band width)	1.8×10^3 / pulse



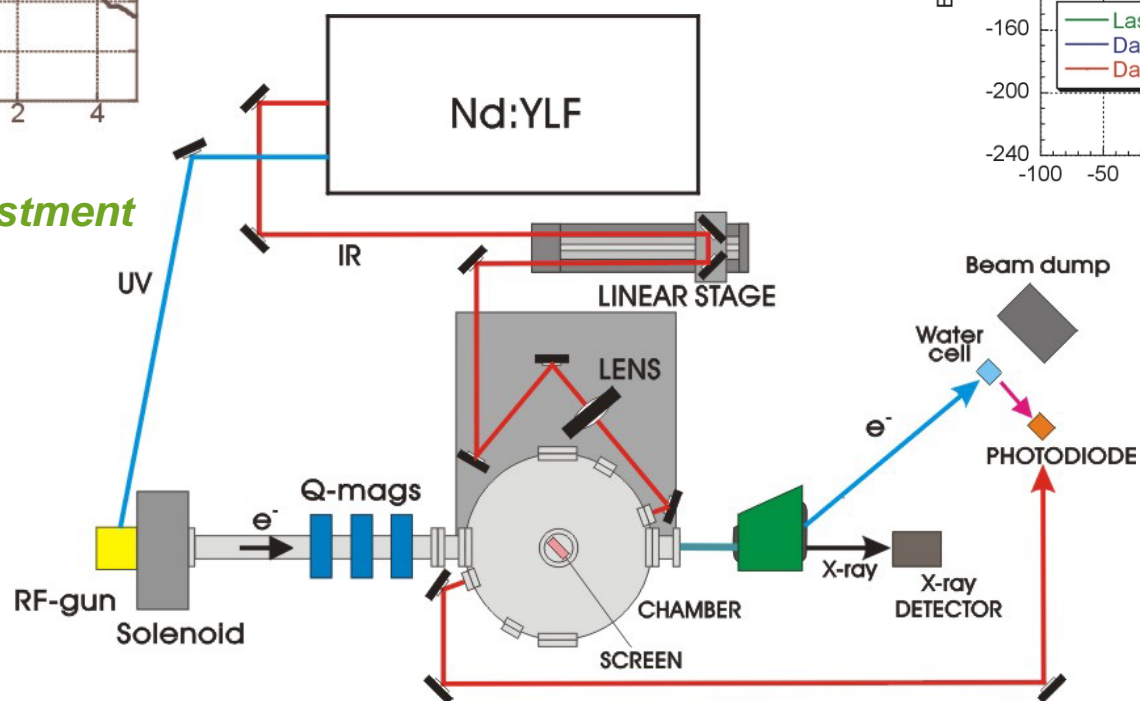
Timing Adjustment and Background Measurement



Timing Adjustment



Detector background



Summary & Future Plan



- Preparing of soft X-ray generation experiment and electron beam characterization have been started.
- We have to perform the optimization of all components.

2002 September ~

- Construct the Laser Amplifier System
- Start the Experiment of Laser Compton Scattering at 20° of the collision angle

2003 ~

- Soft X-ray generation will be performed at 20° , 60° , 90° of the collision angle

In Future

- Application to the soft X-ray microscopy
- Construct the X-ray focusing system for biological observation.